CONTENTS

Preface

.

vii

CHAPTER I EVAPORATION

Introduction	1
Oxidation	4
Evaporative Coating	6
Atoms and Molecules	7
Diameters of Molecules	9
Distances between Molecules in the Gaseous State	11
Velocities of Gas Molecules	17
Evaporation in a Vacuum	19

CHAPTER II VACUUM TECHNOLOGY

Mechanical Vacuum Pump	24
Pumping Speed of a Mechanical Pump	25
Pressure Measurement	28
Thermocouple Vacuum Gauge	30
Impacts of Gas Molecules against Solid Surfaces	
in a Vacuum Chamber	32

v

CONTENTS

Diffusion Pump	36
Ionization Gauge	40
Pumping Limits, Baffles, and Cold Traps	42
A Vacuum System	44
Vacuum Chamber and Feedthroughs	46
Pumping Limits Due to Outgassing	50
Meissner Traps	54
Leak Detecting	57
Maintenance of Vacuum Pumps	60
Other Vacuum Pumps and Gauges	62

CHAPTER III VACUUM EVAPORATION

Vapor Pressure	65
Evaporation Temperature and Pressure	66
Vacuum Evaporation Sources	75
Electron-Beam Sources	81
Evaporation of Alloys and Compounds	83
Film Thickness Measurement and Control	83
Substrate Cleaning	87

CHAPTER IV SPUTTERING

Ion Bombardment of a Surface	92
Glow Discharge	96
The Langmuir Probe	105
The Triode Sputtering System	108
Radio-Frequency Sputtering	123
Unique Characteristics of Sputtering	130
Ion Plating	131

CHAPTER V THIN FILMS

Photolithography	138
General Applications	140
Specific Applications	143

Index

149